WEST Search History

DATE: Monday, April 14, 2003

Set Name	Query	Hit Count	Set Name
side by side			result set
	DB=USPT,PGPB,JPAB,EPAB,DWPI,TDBD; PLUR=YES; OP=ADJ		
L33	l30 same (low K or damascene)	21	L33
L32	L31 and l30	105	L32
L31	L24 or ((438/745)!.CCLS.)	11688	L31
L30	((fluorin$5 hydrocarbon) or (fluor$7 with organic)) same ((wafer or semiconductor or substrate) with (clean$3 or etch$3 or strip$5 or remov$3))	854	L30
L29	L24	11057	L29
L28	L27 and l24	3	L28
L27	L25 and ((wafer or semiconductor or substrate) with (clean$3 or etch$3 or strip$5 or remov$3))	27	L27
L26	L25 same ((wafer or semiconductor or substrate) with (clean$3 or etch$3 or strip$5 or remov$3))	2	L26
L25	(acetyl fluoride) or (fluoride acetate)	523	L25
L24	l9 or ((134/22.19)!.CCLS.)	11057	L24
	DB=JPAB; PLUR=YES; OP=ADJ		
L23	JP2000309172	1	L23
L22	JP2000-309172	0	L22
	DB=JPAB,EPAB,DWPI; PLUR=YES; OP=ADJ		
L21	2000-309172	1	L21
	DB=USPT,PGPB,JPAB,EPAB,DWPI,TDBD; PLUR=YES; OP=ADJ		
L20	L19 and (damascene or low K)	14	L20
L19	l17 and l9	86	L19
L18	L17 same (damascene or low K or Flare or Silk or BCB)	24	L18
L17	((acetyl fluoride) or (fluoride acetate) or fluorin$6) same ((solvent or solution or strip$5) with organic$5)	8340	L17
L16	L14 same (damascene or low K)	21	L16
L15	L14 and l9	146	L15
L14	l12 same ((wafer or semiconductor or substrate) with (clean$3 or etch$3 or strip$5 or remov$3))	1433	L14
L13	L12 and l9	363	L13
L12	((acetyl fluoride) or fluorin$6) same (solvent or solution or strip$5)	41687	L12
L11	L10 same (fluorin$5)	14	L11
L10	(damascene or (dual damascene)) same ((clean$3 or treat$3 or remov$3) with (sol$6 or wet$4))	357	L10
L9	((134/1.2 |134/2 |134/3 |134/26 |134/28 |134/902)!.CCLS. |(216/67 |216/78 |216/81 |216/95 |216/104 |216/105 |216/106 |216/107 |216/108	10610	L9

|216/109)!.CCLS. |(438/906)!.CCLS.)

L8	(damascene or (dual damascene)) same ((clean$3 or treat$3 or remov$3) with (organic adj3 sol$6))	11	L8

DB=USPT; PLUR=YES; OP=ADJ

L7	L1 and ((organic or solvent) same (plasma or sputter$5))	3	L7
L6	L1 and ((organic or solvent) same plasma)	3	L6
L5	L1 and (organic same fluorin$5)	1	L5
L4	L1 and (organic or solvent)	4	L4
L3	6554002.pn.	0	L3
L2	L1 and (organic solvent with fluorine)	0	L2
L1	(6511916 or 6440873 or 6554002 or 6453915 or 6303482).pn.	4	L1

END OF SEARCH HISTORY

WEST Search History

DATE: Monday, April 14, 2003

Set Name side by side	Query	Hit Count	Set Name result set
DB=USPT; PLUR=YES; OP=ADJ			
L18	6372700.pn.	1	L18
DB=USPT,JPAB,EPAB,DWPI; PLUR=YES; OP=ADJ			
L17	L15 same (semiconductor or wafer or substrate or damascene or low k)	28	L17
L16	L15 and (semiconductor or wafer or substrate or damascene or low k)	78	L16
L15	L6 same (clean$3)	267	L15
L14	L6 same (clean$3 or strip$5 or rins$3)	306	L14
L13	L7 and (damascene or low k)	1	L13
L12	L7 same (damascene or low k)	0	L12
L11	L7 and damascene	0	L11
L10	L7 same damascene	0	L10
L9	L7 same (semiconductor or wafer or substrate or damascene)	39	L9
L8	L7 and (semiconductor or wafer or substrate or damascene)	117	L8
L7	L6 same (clean$3 or etch$3 or strip$5 or rins$3)	334	L7
L6	L3 same (solvent or solution or wet$3)	2287	L6
L5	L4 and (semiconductor or wafer or substrate or damascene)	88	L5
L4	L3 with clean$3	279	L4
L3	L2 or fluorohydrocarbon	8678	L3
L2	L1 or fluorinated hydrocarbon	6508	L2
L1	fluoride acetate or acetyl fluoride	509	L1

END OF SEARCH HISTORY

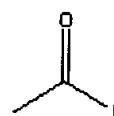Enter a Chemical Name, CAS Number, Molecular Formula or Weight.
Use * for partial names (e.g. ben*).
Search here for free. For professional searching, use ChemINDEX.

Search

Acetyl fluoride [557-99-3]
Synonyms: Acetyl fluoride; Acetyl fluoride, 99% (Assay);

Tools
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CAS RN Lookup
THE MERCK INDEX
NCI DATABASE

OpenChem
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ADD LINK

Formula	C_2H_3FO	Molecular Weight	62.0435
CAS RN	557-99-3	Melting Point (°C)	
ACX Number	X1041227-8	Boiling Point (°C)	
Density		Vapor Density	
Refractive Index		Vapor Pressure	
Evaporation Rate		Water Solubility	
Flash Point (°C)		EPA Code	
DOT Number		RTECS	
Comments			

More information about the chemical is available in these categories:

Chemical Online Order (1)
Available Chemicals Exchange

Information about this particular compound

Physical Properties (2)
ABCR GmbH&Co KG
   Acetyl fluoride; 96%
NIST Chemistry WebBook
   Information about this particular compound

Enter a Chemical Name, CAS Number, Molecular Formula or Weight.
Use * for partial names (e.g. ben*).
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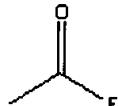[   ]   Search

CambridgeSoft.Com | ChemStore.Com | ChemFinder.Com | ChemNews.Com | ChemClub.Com

Enter a Chemical Name, CAS Number, Molecular Formula or Weight.
Use * for partial names (e.g. ben*).
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Search

Acetyl fluoride [557-99-3]
Synonyms: Acetyl fluoride; Acetyl fluoride, 99% (Assay);

Tools

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Formula	C_2H_3FO	Molecular Weight	62.0435
CAS RN	557-99-3	Melting Point (°C)	
ACX Number	X1041227-8	Boiling Point (°C)	
Density		Vapor Density	
Refractive Index		Vapor Pressure	
Evaporation Rate		Water Solubility	
Flash Point (°C)		EPA Code	
DOT Number		RTECS	
Comments			

More information about the chemical is available in these categories:

Chemical Online Order (1)
Available Chemicals Exchange

Information about this particular compound

Physical Properties (2)
ABCR GmbH&Co KG
   Acetyl fluoride; 96%
NIST Chemistry WebBook
   Information about this particular compound

Enter a Chemical Name, CAS Number, Molecular Formula or Weight.
Use * for partial names (e.g. ben*).
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Inventor Name Search Result

Your Search was:

Last Name = WU
First Name = CHIH-NING

Application#	Patent#	Status	Date Filed	Title	Inventor Name
10356754	Not Issued	030	02/03/2003	ETCHING PROCESS FOR FORMING DAMASCENE STRUCTURE OF THE SEMICONDUCTOR	WU, CHIH-NING
10248281	Not Issued	030	01/06/2003	METHOD FOR ELIMINATING NODULE DEFECTS DURING A DUAL DAMASCENE PROCESS	WU, CHIH-NING
10036363	6511916	150	01/07/2002	METHOD FOR REMOVING THE PHOTORESIST LAYER IN THE DAMASCENE PROCESS	WU, CHIH-NING
09841817	Not Issued	071	04/24/2001	METHOD OF CLEANING A DUAL DAMASCENE STRUCTURE	WU, CHIH-NING
09795754	Not Issued	083	02/28/2001	POST-ETCHING CLEANING PROCESS IN DUAL DAMASCENE STRUCTURE MANUFACTURING	WU, CHIH-NING
09792952	6440873	150	02/26/2001	POST METAL ETCH CLEANING METHOD	WU, CHIH-NING
09791027	6495472	150	02/21/2001	METHOD FOR AVOIDING EROSION OF CONDUCTOR STRUCTURE DURING REMOVING ETCHING RESIDUES	WU, CHIH-NING
09789357	Not Issued	041	02/20/2001	METHOD OF CLEANING A DUAL DAMASCENE STRUCTURE	WU, CHIH-NING
09789349	6554002	150	02/21/2001	METHOD FOR REMOVING ETCHING RESIDUES	WU, CHIH-NING
09789348	Not Issued	161	02/21/2001	CLEAN METHOD AFTER IMPLANTATION OF LIGHTLY DOPED DRAIN	WU, CHIH-NING
09682054	Not Issued	041	07/16/2001	EXTRUSION-FREE WET	WU, CHIH-NING

				CLEANING PROCESS FOR COPPER-DUAL DAMASCENE STRUCTURES	
09607022	6453915	150	06/29/2000	POST POLYCIDE GATE ETCHING CLEANING METHOD	WU, CHIH-NING
09597762	6303482	150	06/19/2000	METHOD FOR CLEANING THE SURFACE OF A SEMICONDUCTOR WAFER	WU, CHIH-NING
09597748	Not Issued	161	06/19/2000	METHOD FOR CLEANING THE SURFACE OF A SEMICONDUCTOR WAFER	WU, CHIH-NING
08796470	6060415	150	02/10/1997	ALIGNED MOLECULAR SIEVE CRYSTALS GROWN ON ANODIC ALUMINA MEMBRANE	WU , CHIH-NING

Inventor Search Completed: No Records to Display.

Search Another:
Inventor

Last Name	First Name
wu	chih-ning

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Inventor Name Search Result

Your Search was:

Last Name = CHIEN
First Name = SUN-CHIEH

Application#	Patent#	Status	Date Filed	Title	Inventor Name
10192954	Not Issued	030	07/11/2002	MEMORY STRUCTURE WITH THIN FILM TRANSISTOR AND METHOD FOR FABRICATING THE SAME	CHIEN, SUN-CHIEH
10050258	Not Issued	030	01/16/2002	METHOD OF FABRICATING SYSTEM ON CHIP DEVICE	CHIEN, SUN-CHIEH
09885049	6461959	150	06/21/2001	METHOD FOR FABRICATION OF A CONTACT PLUG IN AN EMBEDDED MEMORY	CHIEN, SUN-CHIEH
09841817	Not Issued	071	04/24/2001	METHOD OF CLEANING A DUAL DAMASCENE STRUCTURE	CHIEN, SUN-CHIEH
09819751	6395596	150	03/29/2001	METHOD OF FABRICATING A MOS TRANSISTOR IN AN EMBEDDED MEMORY	CHIEN, SUN-CHIEH
09803881	6403417	150	03/13/2001	METHOD FOR IN-SITU FABRICATION OF A LANDING VIA AND A STRIP CONTACT IN AN EMBEDDED MEMORY	CHIEN, SUN-CHIEH
09803880	Not Issued	161	03/13/2001	METHOD FOR FABRICATING A MOS TRANSISTOR OF AN EMBEDDED MEMORY	CHIEN, SUN-CHIEH
09801253	6509216	150	03/07/2001	MEMORY STRUCTURE WITH THIN FILM TRANSISTOR AND METHOD FOR FABRICATING THE SAME	CHIEN, SUN-CHIEH
09799909	6406971	150	03/06/2001	FABRICATION METHOD FOR AN EMBEDDED DYNAMIC RANDOM ACCESS MEMORY (DRAM)	CHIEN, SUN-CHIEH

09798857	6468838	150	03/01/2001	METHOD FOR FABRICATING A MOS TRANSISTOR OF AN EMBEDDED MEMORY	CHIEN, SUN-CHIEH
09795754	Not Issued	083	02/28/2001	POST-ETCHING CLEANING PROCESS IN DUAL DAMASCENE STRUCTURE MANUFACTURING	CHIEN, SUN-CHIEH
09795327	Not Issued	161	03/01/2001	METHOD FOR FABRICATING A MOS TRANSISTOR OF AN EMBEDDED MEMORY	CHIEN, SUN-CHIEH
09789357	Not Issued	041	02/20/2001	METHOD OF CLEANING A DUAL DAMASCENE STRUCTURE	CHIEN, SUN-CHIEH
09767499	6406968	150	01/23/2001	METHOD OF FORMING DYNAMIC RANDOM ACCESS MEMORY	CHIEN, SUN-CHIEH
09764334	6509223	150	01/19/2001	METHOD FOR MAKING AN EMBEDDED MEMORY MOS	CHIEN, SUN-CHIEH
09764333	6509235	150	01/19/2001	METHOD FOR MAKING AN EMBEDDED MEMORY MOS	CHIEN, SUN-CHIEH
09764330	6436759	150	01/19/2001	METHOD FOR FABRICATING A MOS TRANSISTOR OF AN EMBEDDED MEMORY	CHIEN, SUN-CHIEH
09764328	6465364	150	01/19/2001	METHOD FOR FABRICATION OF A CONTACT PLUG IN AN EMBEDDED MEMORY	CHIEN, SUN-CHIEH
09764327	Not Issued	095	01/19/2001	METHOD FOR FABRICATING A MOS TRANSISTOR OF AN EMBEDDED MEMORY	CHIEN, SUN-CHIEH
09764326	6468919	150	01/19/2001	METHOD OF MAKING A LOCAL INTERCONNECT IN AN EMBEDDED MEMORY	CHIEN, SUN-CHIEH
09755104	Not Issued	161	01/08/2001	METHOD FOR FORMING A DUAL DAMASCENE OPENING BY LIQUID PHASE DEPOSITION	CHIEN, SUN-CHIEH
09729547	Not Issued	161	12/04/2000	METHOD FOR FABRICATING EMBEDDED DYNAMIC RANDOM	CHIEN, SUN-CHIEH

				ACCESS MEMORY	
09725027	6432827	150	11/29/2000	ILD PLANARIZATION METHOD	CHIEN, SUN-CHIEH
09510970	6432768	150	02/21/2000	METHOD OF FABRICATING MEMORY DEVICE AND LOGIC DEVICE ON THE SAME CHIP	CHIEN, SUN-CHIEH
09216022	6284647	150	12/16/1998	METHOD TO IMPROVE THE UNIFORMITY OF CHEMICAL MECHANICAL POLISHING	CHIEN, SUN-CHIEH
09200120	Not Issued	161	11/25/1998	METHOD OF DEFINING A MASK PATTERN FOR A PHOTORESIST LAYER IN SEMICONDUCTOR FABRICATION	CHIEN, SUN-CHIEH
09192877	6200880	150	11/16/1998	METHOD FOR FORMING SHALLOW TRENCH ISOLATION	CHIEN, SUN-CHIEH
09192042	6281081	150	11/13/1998	METHOD OF PREVENTING CURRENT LEAKAGE AROUND A SHALLOW TRENCH ISOLATION STRUCTURE	CHIEN, SUN-CHIEH
09181302	6169016	150	10/28/1998	METHOD OF FORMING CONTACT	CHIEN, SUN-CHIEH
09172407	6140201	150	10/14/1998	METHOD FOR FABRICATING A CYLINDER CAPACITOR	CHIEN, SUN-CHIEH
09009508	6121085	150	01/20/1998	METHOD OF FABRICATING CONTACT OPENINGS FOR DYNAMIC RANDOM-ACCESS MEMORY	CHIEN, SUN-CHIEH
08997448	5895256	150	12/23/1997	METHOD FOR MANUFACTURING LOCOS STRUCTURE	CHIEN, SUN-CHIEH
08975497	6159788	150	11/21/1997	METHOD TO INCREASE DRAM CELL CAPACITANCE	CHIEN, SUN-CHIEH
08975495	5946571	150	11/21/1997	METHOD OF FORMING A CAPACITOR	CHIEN, SUN-CHIEH
08975488	6008080	150	11/21/1997	METHOD OF MAKING A LOW POWER SRAM	CHIEN, SUN-CHIEH
08962116	5985709	150	10/31/1997	A PROCESS FOR FABRICATING A TRIPLE-WELL STRUCTURE	CHIEN, SUN-CHIEH

PALM INTRANET

Day : Monday
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Time: 14:57:46

Inventor Name Search Result

Your Search was:

Last Name = CHIEN
First Name = SUN-CHIEH

Application#	Patent#	Status	Date Filed	Title	Inventor Name
09439932	6281067	150	11/12/1999	SELF-ALIGNED SILICIDE PROCESS FOR FORMING SILICIDE LAYER OVER WORD LINES IN DRAM AND TRANSISTORS IN LOGIC CIRCUIT REGION	CHIEN , SUN-CHIEH
08896670	Not Issued	161	07/18/1997	PLANARIZATION METHOD FOR IC PRODUCTION	CHIEN , SUN-CHIEH

Inventor Search Completed: No Records to Display.

	Last Name	First Name
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